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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named
Inventor : Stanislav V. Aleshin et al.

Appln. No.: 09/879,664

Filed : June 12, 2001

For : MASK CORRECTION FOR
PHOTOLITHOGRAPHIC PROCESSES

Docket No.: L13.12-0149/01-026

Group Art Unit: 2621

Examiner:

LETTER TO OFFICIAL DRAFTSPERSON

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David D. Brush
PATENT ATTORNEY

Sir:

Enclosed are **three** (3) sheets of formal drawings for
filing in the above-identified application.

Respectfully submitted,

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By:

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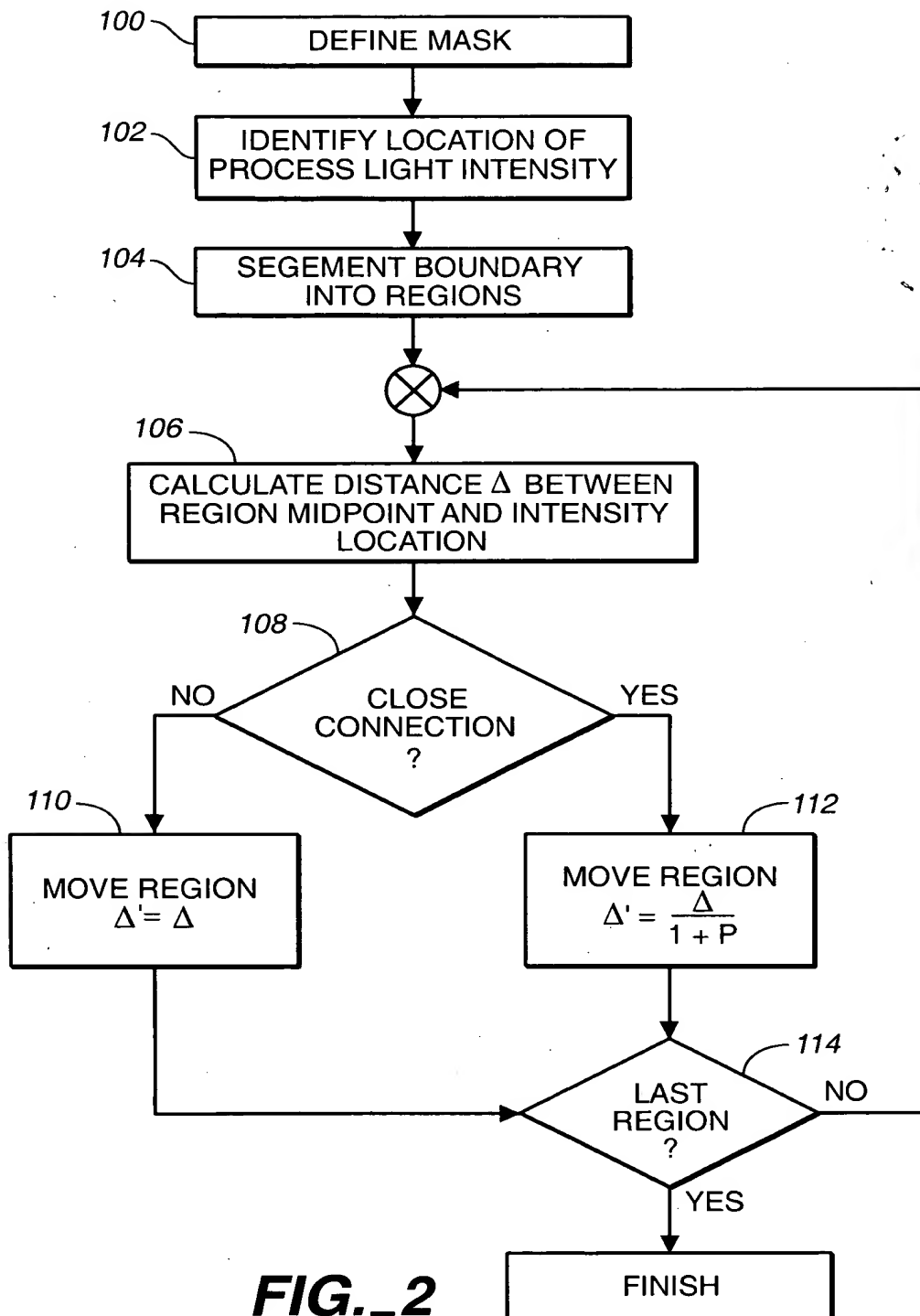
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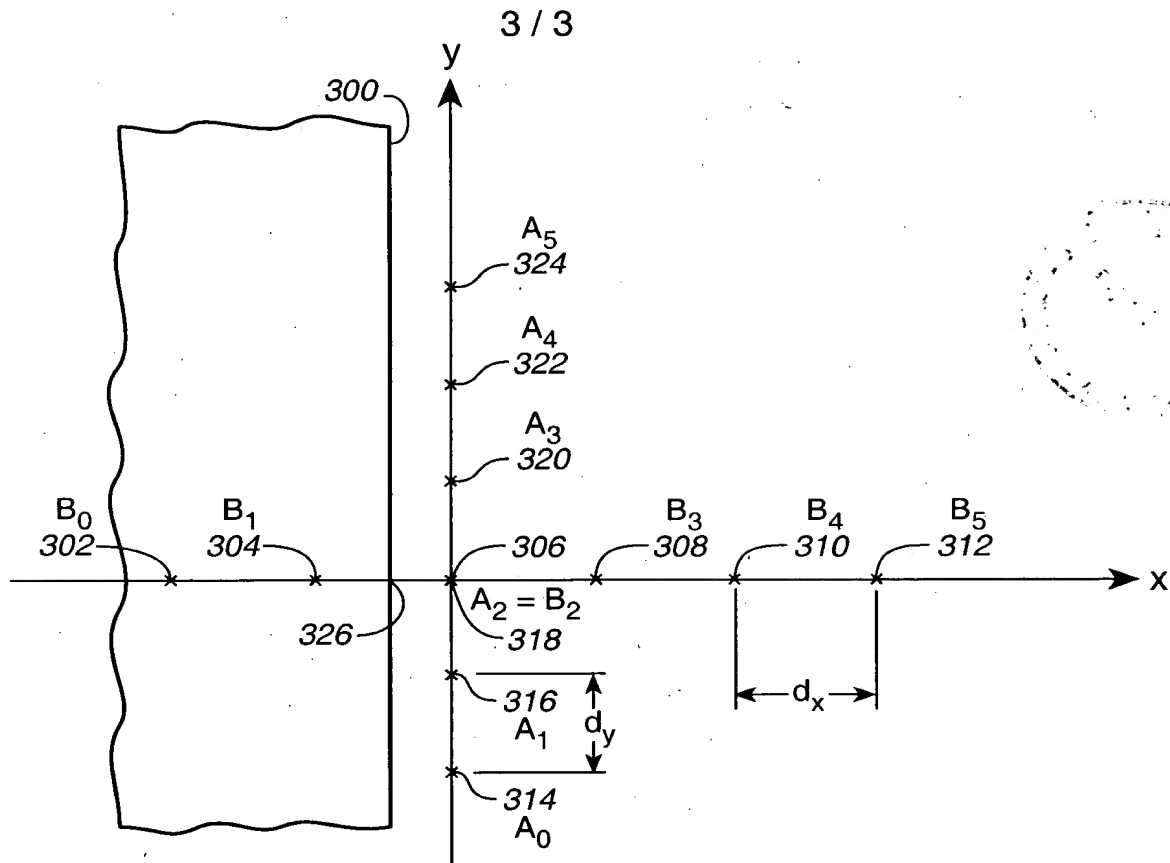
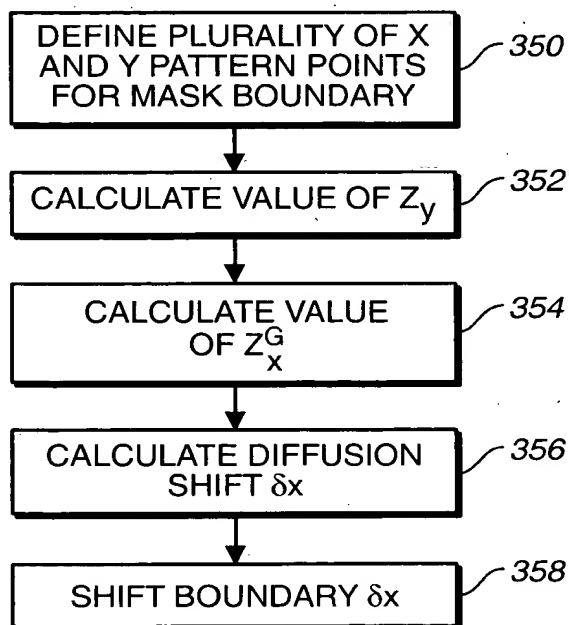


FIG. 3



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**FIG. 2**

**FIG. 5****FIG. 6**